General Methodological Issues Development of IP Statistics

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Outline

- 1. Introduction
- 2. Data sources and final products: Issues to be considered
- 3. Example: IIP-Patent Database in Japan
- Use of external complementary data such as PATSTAT

1.Introduction

- Difficulty in measuring knowledge despite the talk of "knowledge society"
- Patent (and other IP) as a source of information on technological knowledge
- Private (academic) contribution to IP based database (such as NBER patent database, EPIP, IIP ...). "Open Innovation Model" for patent offices

2. Data sources and final products

Publication data

 IP front page, such as title, IPC codes, dates, applicants

Internal records of IP offices

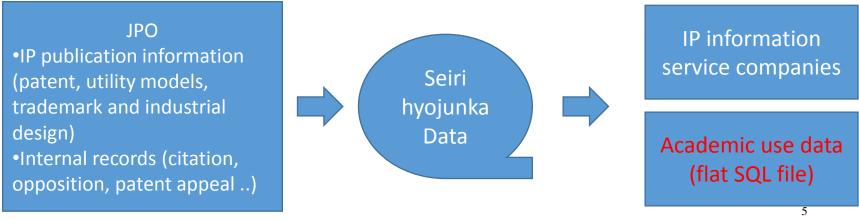
examiner citation,pre (post) grantopposition...

IP statistics database

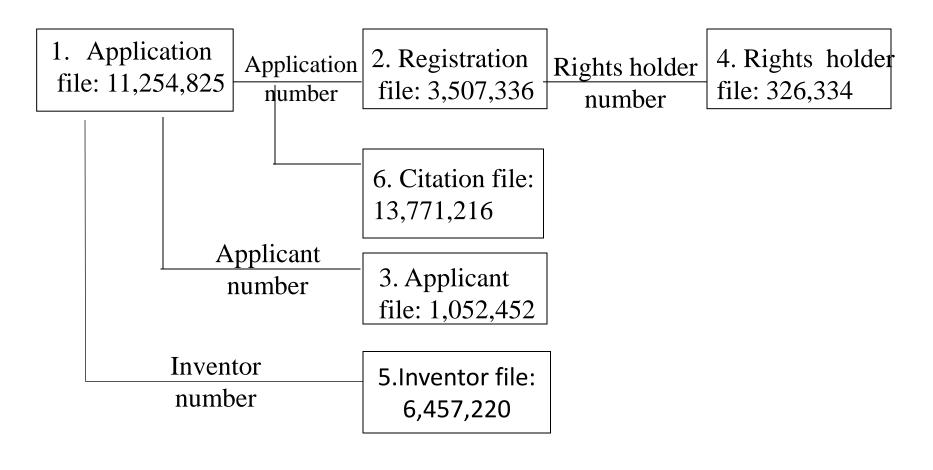
- IT system inside IP office: electronics filing and examination system?, Internal recording?
- Purpose of IP statistics development: database design and construction

3. Example: IIP patent data

- Original Data Source; JPO Seiri hyojunka Data
 - (Literally translating, "Arranged and Standardized Data", hereafter, JPO Patent Database)
 - It contains the information generated through acceptance of application to examination process by JPO, released 25 times a year (every two weeks).
 - About 50 boxes of half inch tape+DVD-ROM recently.
- SQL database: Voluntary initiative by academic group with a help of IIP (Institute of Intellectual Property: JPO related non profit organization) for constructing database for academic use



Structure of IIP Patent Database



- The data from 1964 patent application are included
- Original information is preserved

Importance of normalization for relational database

Patent #	Technology class	Applicant name	Applicant address	
1	A61K	XXX co. ltd	Tokyo	
1	C12N	XXX co. ltd	Tokyo	
1	A61K	ZZZ university	Osaka	
1	C12N	ZZZ university	Osaka	
1	A61K	Mr. YYY	Sapporo	
1	C12N	Mr. YYY	Sapppro	



Patent #	IPC		
1	A61K		
1	C12N		



Patent #	Applicant #
1	1
1	2
1	3

Applicant #	Applicant name	Applicant address
1	XXX co. ltd	Tokyo
2	ZZZ university	Osaka
3	Mr. YYY	Sapporo

1) Patent application files

- Application number
- Application date
- Examination request date
- Applicant number
- Number of claims at patent application
- Lead IPC code at patent application
- Aggregated technology category

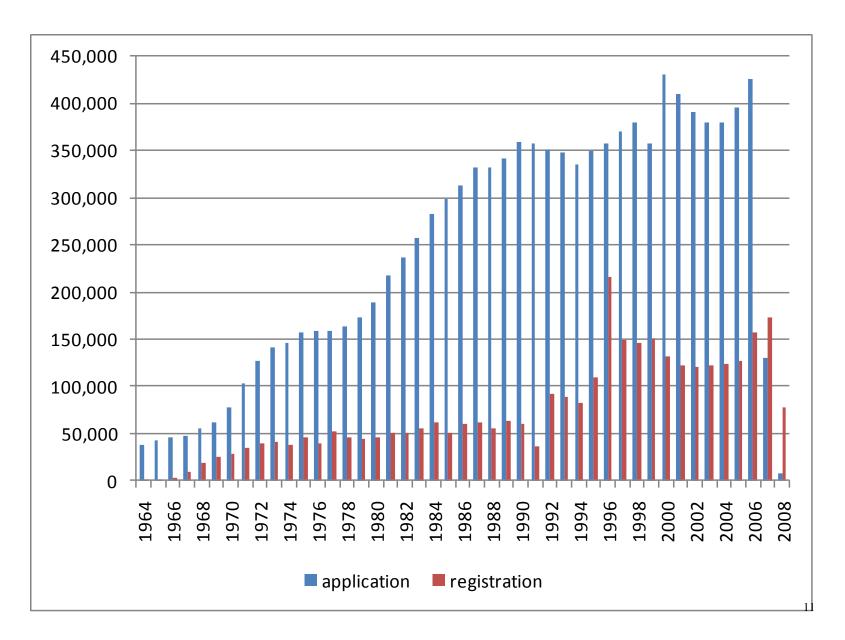
Aggregated Technology Category

Tech No	Title		Corresponding IPC			NBER
1	A griculture	A 01			ExceptA01N)	6
2	Food Stuffs	A 21	~	A 24		6
3	3 Personal and Domestic Articles		~	A 47		6
4	4 Health and Amusement		~	A 63	Except A61K)	3
	D rugs					3
6	Separating, M ixing	B01	~	B 09		1
7	M achine tools, M etal working	B21	~	0 20		5
	Casting, Grinding, Layered Product	B 24	~		Except B31)	5
	Printing	B41	~	B 44		6
	Transporting	B 60	~	B 64		5
11	Packing, Lifting	B 65	~	B 68		5
12	Non organic chem istry, Fertilizer	C 01	~	C 05		1
13	0 rgan ic chem istry, Pesticides	C 07	,	A 01N		1
14	Organic molecule compounds	C 08				1
15	Dyes, Petro leum	C 09	~	C11		1
16	B btechnobgy, Beer, Ferm entation	C12	~	C14		3
17	Genetic Engineering	C 12N	15/			3
18	M eta lurgy, C oating m eta s	C 21	~	C 30		5
19	Textile	D01	~	D 07		6
20	Paper	D21		B31		6
21	Construction	E01	~	E06		6
22	M n ng, D rillng	E21				6
23	Engine, Pum p	F01	~	F04	、F15	5
24	Engineering elements	F16	~	F17		5
25	Lighting, Steam generation, Heating	F21	~	F28		6
	W eapons, B lasting	F41	~	F42	. C06	6
27	M easurem ent, 0 ptics, Photography	G 01	~	G 03		4
28	C bck, Controlling, Computer	G 04	~	G 08		2
29	D isplay, Information Storage, Instruments	G 09	~	G 12		2
	Nuc ear physics	G 21				4
31	Electronics components, sem iconductor	H01	~	H02	. H05	4
	Electronics circuit, communication tech.	H03	~	H04		2
33	0 thers	B81		B 82		6

2 Patent registration file

- Application number
- Registration number
- Registration date
- Rights expiration date
- Rights holder number
- Number of claims at patent registration
- Lead IPC code at patent registration
- Aggregated technology category

of observation by year



3 Applicant file

- Applicant number
- Applicant name
- Applicant type (individual, corporation or government)
- Country and prefecture code
- JPO applicant code

4 Rights holder file

- Rights holder number
- Rights holder name
- Rights holder address

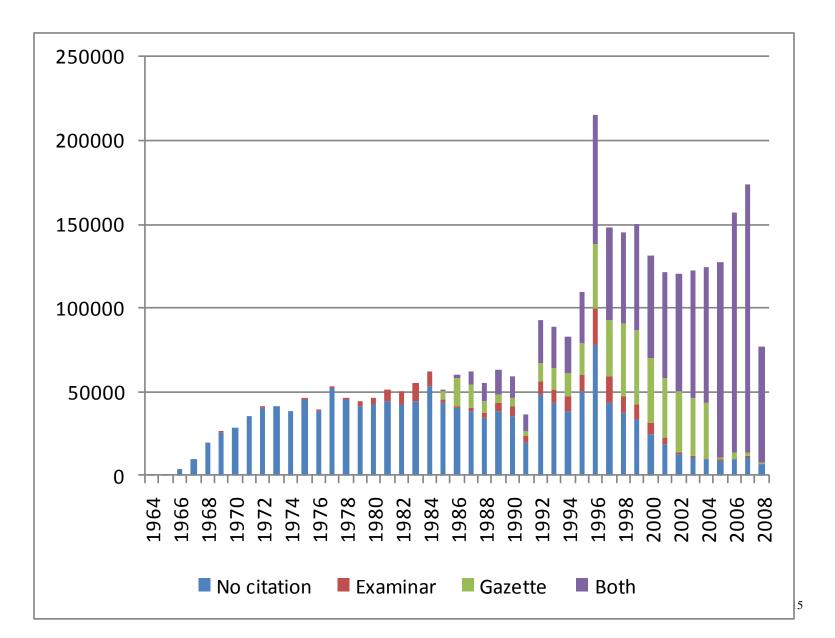
5 Inventor file

- Inventor number
- Inventor name
- Inventor address

6 Citation information file

- Citing patent application number
- Cited patent application number
- Citation type

Registration patent by citation type



4. Use of external complementary data such as PATSTAT

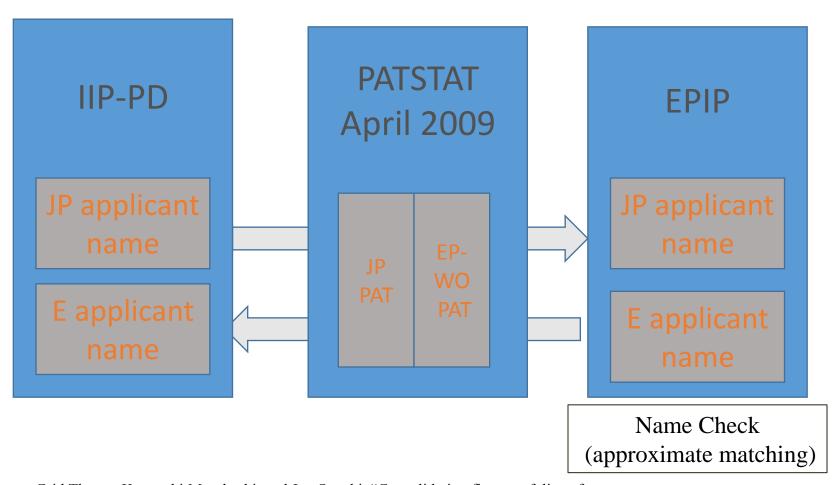
Linking with patent database in other countries/regions by patent family information

- complementing information for internal datasets
- add new variables as a patent quality indicator

Useful data source: PATSTAT

- ◆ 80 million patent application information from over 70 patent authority
- Originated from DOC-DB (EPO's master documentation database)

Applicant name harmonization works for IIP-PD and EPIP database



Grid Thoma, Kazuyuki Motohashi, and Jun Suzuki, "Consolidating firm portfolios of patents across different offices. A comparison of sectoral distribution of patenting activities in Europe and Japan", IAM Discussion Paper Series #019, 2010/11

Useful sources

IIP Patent Database

http://www.iip.or.jp/e/e_patentdb/index.html

IIP PD methodological paper

Akira Goto and Kazuyuki Motohashi, "Construction of a Japanese Patent Database and a first look at Japanese patenting activities", Research Policy 36(9), 2007/11, pp.1431-1442

Patent database development works in other countries (for Asian countries, not covered well by PATSTAT)

<u>China:</u> Kazuyuki Motohashi, "Assessment of technological capability in science industry linkage in China by patent database", World Patent Information 30(3), September 2008, Pages 225-232

India: work undergoing

For other nations